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| Substitute for form 1449A&B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i> | | | | Complete if Known | |
| | | | | Application Number | 10/757,770 |
| | | | | Filing Date | January 14, 2004 |
| | | | | First Named Inventor | Yuan, Zheng |
| | | | | Art Unit | 1792 |
| | | | | Examiner Name | Kelly M. Stouffer |
| Sheet | 1 | of | 7 | Attorney Docket Number | 016301-052200US |

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| Examiner Signature | | | | Date Considered | |

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| | FW | BAKER, F. et al. "STI TEOS Densification for Furnaces and RTP Tools" 1999 IEEE/SEMI Advanced Semiconductor Manufacturing Conference, 1999, pp. 394-399. | <input type="checkbox"/> |
| | FX | Bang et al. (Jan. 3 , 2002). US Patent Application Publication US-2002-0000195 A1. | <input type="checkbox"/> |
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